

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant :	Hideto Ohnuma et al.	Art Unit :	2812
Serial No. :	09/925,512	Examiner :	Richard A. Booth
Filed :	August 10, 2001	Confirmation No.:	4989
Title :	METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE		

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

STATEMENT RE RELATED APPLICATION

Applicants wish to bring to the Examiner's attention related application Serial No. 11/224,047, filed September 13, 2005, which was published as US 2006-0014335 A1 on January 19, 2006.

This statement is being filed before receipt of an Office Action following the re-opening of prosecution on May 26, 2006. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: _____

6/29/06



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Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 12732-068001	Application No. 09/925,512
Information Disclosure Statement by Applicant (Use several sheets if necessary)		Applicant Hideto Ohnuma et al.	
		Filing Date August 10, 2001	Group Art Unit 2812
(37 CFR §1.98(b))			

U.S. Patent Documents

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	2006-0014335	01/19/2006	Ohnuma et al.			09/13/2005
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
	AQ	
	AR	
	AS	
	AT	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	